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Applicants : Chandra V. Mouli and Ceredig Roberts
Serial No. : 09/648,044
Filed : August 25, 2000
Confirm No. : 6800
Title : METHOD AND DEVICE TO REDUCE GATE-INDUCED DRAIN
LEAKAGE (GIDL) CURRENT IN THIN GATE OXIDE MOSFETS
Docket No. : MIO 0054 PA
Examiner : O. Nadav
Art Unit : 2811

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of
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Assistant Commissioner for Patents
Washington, D.C. 20231

William A. Jividen

42,695
Reg. No.

Sir:

RESPONSE TO RESTRICTION REQUIREMENT

This paper is being filed in response to the Office Action of October 31, 2001. Applicant hereby elects claims 1-14 for prosecution on the merits.

Applicants respectfully submit that the application is in condition for allowance. The Examiner is encouraged to contact the undersigned to resolve efficiently any formal matters or to discuss any aspects of the application or of this response. Otherwise, early notification of allowable subject matter is respectfully solicited.

Respectfully submitted,

KILLWORTH, GOTTMAN, HAGAN &
SCHAEFF, L.L.P.

By

William A. Jividen
Registration No. 42,695

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